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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application

Applicant(s): Hiroshi Inagaki et al.

Serial No.: 10/588,533

Filed: August 7, 2006


For: **Single Crystal Semiconductor
Manufacturing Apparatus and
Method**

Examiner: Felisa Carla Hiteshew

) Art Unit: 1722

) Confirmation No.: 9556

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) 
) Gerald T. Shekleton Reg. No. 27,466

AMENDMENT

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, Virginia 22313-1450

Dear Sir:

The Office Action of September 24, 2007 and the following amendments and remarks are made in response thereto.